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Art Unit: 1756

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Subject Matter: 10/050,322 Attorney Doc: 67,200-613

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U.S.S.N. 10/050,322

OCT 27 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tsai et al.

Group Art Unit: 1756

Serial No.: 10/050,322

Examiner: N. M. Barreca

Filed: 01/15/2002

In Response to Office Action
Dated: 08/24/2004

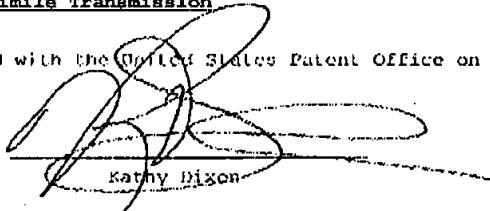
For: A BI-LAYER PHOTORESIST DRY DEVELOPMENT AND
REACTIVE ION ETCH METHOD

Attorney Docket No.: 67,200-613

Certificate of Facsimile Transmission

I hereby certify that this paper is being deposited with the United States Patent Office on the date shown below via Facsimile no. (703) 872-9311.

Date: Oct. 27 , 2004


Kathy Dixon

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Advisory Action mailed 08/24/2004,
please enter the following proposed amendments to place the
claims in better form and remove issues on Appeal.